

PATENT

Docket No. JCLA6353

Date: (5-23-200/

Page 1

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

ATTENTION: APPLICATION BRANCH

Sir:

Transmitted herewith for filing is the patent application of

Inventors: Chingfu Lin; Hsueh-Chung Chen

For: A DUAL DAMASCENE PARTIAL GAP FILL POLYMER FABRICATION PROCESS

Enclos	sed are:
\boxtimes	Specification 13 pages.
	5 Sheets of drawings
.₩	Recordation Form Cover sheet with 2 pages assignment.
	A certified copy of Taiwan Patent Application No dated
\boxtimes	SIGNED declaration and power of attorney.
\boxtimes	Return Prepaid postcard.

CLAIMS AS FILED									
FOR	NUMB	ER FII	ED N	UMBEI	REXTRA	RATE	FEE		
Basic Fee						\$710.00	\$710.00		
Total Claims	16	_	20 =	0	×	\$18.00	\$0.00		
Independent Claims	1	_	3 =	0	×	\$80.00	\$0.00		
If application contains any r	\$270.00	\$0.00							
_	TOTAL	FILING	FEE	_			\$710.00		

A check in the amount of \$710.00 cover the filing fee is enclosed.

A check in the amount of \$40.00 to cover the assignment recording fee.

A duplicate copy of this sheet is enclosed.

Jiawei Huang

Registration No. 43,330

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J.C. PATENTS, INC.

1340 REYNOLDS AVE., SUITE 114 IRVINE, CALIFORNIA 92614

(949) 660-0761

FAX: (949) 660-0809

Assistant Commissioner for Patents Washington, D.C. 20231

CERTIFICATE OF MAILING BY "EXPRESS MAIL"

Docket No.

: JCLA6353

Applicant(s)

: Chingfu Lin; Hsueh-Chung Chen

For

: A DUAL DAMASCENE PARTIAL GAP FILL POLYMER

FABRICATION PROCESS

"Express Mail"

: EL800897094US

Mailing Label No.

Date of Deposit

: Mary 23.2001

I hereby certify that the accompanying

Transmittal in Duplicate; Specification <u>13</u> pages, <u>5</u> sheets of drawings; **SIGNED** Declaration and Power of Attorney <u>2</u> pages; Recordation Form Cover Sheet and Assignment <u>3</u> pages; Checks for Filing Fee(s); Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

M. Chang
Michelle Chang